

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jun Koyama et al. Art Unit : Unknown
Serial No. : New DIV Appln. Examiner : Unknown
Filed : July 17, 2003
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Under 35 USC §120, this application relies on the earlier filing dates of application serial number 09/652,652, filed on August 31, 2000 and application serial number 08/996,357, filed December 22, 1997. The attached list of references were submitted to and/or cited by the Office in the prior applications and, therefore, are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 17, 2003



John F. Hayden
Reg. No. 37,640

Fish & Richardson P.C.
1425 K Street, N.W.
11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-209003	Application No. New DIV Appln.
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Jun Koyama et al.	
		Filing Date July 17, 2003	Group Art Unit Unknown

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2001-0022677	09/2001	Hirakata et al.			
	AB	4,914,503	04/1990	Shirato et al.			
	AC	5,491,352	02/1996	Tsuji			
	AD	5,644,147	7/1/1997	Yamazaki et al.			
	AE	5,739,549	04/1998	Takemura et al.			
	AF	5,744,820	04/1998	Matsushima et al.			
	AG	5,780,872	07/1998	Misawa et al.			
	AH	5,804,501	09/1998	Kim			
	AI	5,818,070	10/1998	Yamazaki et al.			
	AJ	5,899,547	05/1999	Yamazaki et al.			
	AK	6,008,065	12/1999	Lee et al.			
	AL	6,072,556	06/2000	Hirakata et al.			
	AM	6,166,396	12/2000	Yamazaki			
	AN	6,198,133	03/2001	Yamazaki et al.			
	AO	6,239,854	05/2001	Hirakata et al.			
	AP	6,384,818	05/2002	Yamazaki et al.			

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
	AQ						Yes	No

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AR	
	AS	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	